GAU 1645

PTO/SB/21 (08-00) ype a plus sign (+) inside this box -Approved for use through 10/31/2002. OMB 0651-0031
U.S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE NOV 0 4 2002 der the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number Application Number 10/081,990 TRANSMITTAL & TRADE Filing Date February 20, 2002 **FORM** First Named Inventor Buddy D. Ratner Group Art Unit (To be used for all correspondence after initial filing) RECEIVED **Examiner Name** Attorney Docket No. ENCLOSURES (check all that apply) <sup>20</sup>7ECH CENTER 1600/2900 Fee Transmittal Form **Assignment Papers** CD(s) Fee Attached (for an Application) of CD(s) Amendment/Response Drawing(s) After Allowance Request for Corrected Filing After Final Communication to Group Affidavits/declaration(s) Appeal Communication to **Extension of Time Request** Licensing-related Papers Board of Appeals and Petition Express Abandonment Interferences Request Petition to Convert to a Appeal Communication to Provisional Application Information Disclosure Group (Appeal Notice, Brief, Statement; Form PTO-1449 Power of Attorney, Reply Brief) Revocation, Change of Cited References **Proprietary Information** Correspondence Address **Certified Copy of Priority** Status Letter Declaration Document(s) Return Receipt Postcard Response to Missing Parts Statement under 37 CFR Additional Enclosure(s) 3.73(b)under 37 C.F.R. 1.52 or 1.53 (please identii **Terminal Disclaimer** Response to Missing Parts/Incomplete Application **Small Entity Statement** Request for Refund Remarks SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT Individual Name Timothy L. Boller 00500 PATENT TRADEMARK OFFICE Signature Date October 30, 2002 **CERTIFICATE OF MAILING** I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231 on the date specified below. Typed or printed name Jason Añover Signature Date: October 30, 2002

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I hereby certify that on the date specified below, this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to the Commissioner for

Patents, Washington, DC 20231.

October 30, 2002 Date

Jason Añover

TECH CENTER 1600/2900

Applicants

Buddy D. Ratner et al.

IN THE UNITED STATES PATENT AND TRADEMARK

Application No.

10/081,990

Filed

February 20, 2002

For

METHOD AND APPARATUS FOR PRECISION COATING OF

MOLECULES ON THE SURFACES OF MATERIALS AND

**DEVICES** 

Art Unit

1645

Docket No.

920010.40001

Date

October 30, 2002

Commissioner for Patents Washington, DC 20231

## INFORMATION DISCLOSURE STATEMENT

## Commissioner for Patents:

In accordance with 37 C.F.R. §§ 1.56 and 1.97 through 1.98, applicants wish to make known to the Patent and Trademark Office the references set forth on the attached form PTO-1449 (copies of the cited references are enclosed). As to any reference supplied, applicants do not admit that it is "prior art" under 35 U.S.C. §§ 102 or 103, and specifically reserve the right to traverse or antedate any such reference, as by a showing under 37 C.F.R. § 1.131 or other method. Although the aforesaid references are made known to the Patent and Trademark Office in compliance with applicants' duty to disclose all information they are aware of which is

believed relevant to the examination of the above-identified application, applicants believe that their invention is patentable.

Please acknowledge receipt of this Information Disclosure Statement and kindly make the cited references of record in the above-identified application.

Respectfully submitted,
Buddy D. Ratner et al.
Seed Intellectual Property Law Group PLLC

Timothy L. Boller

Registration No. 47,435

Enclosures:

Postcard Form PTO-1449 Cited References (8)

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